

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Jason M. Benz

Serial No.: 09/695,028

Group Art Unit: 1765

Filed: October 24, 2000

Examiner: Alanko, Anita K.

For:

METHOD FOR THIN FILM LASER REFLECTANCE CORRELATION FOR

SUBSTRATE ETCH ENDPOINT

Assistant Commissioner of Patents Washington, D.C. 20231

SUBMISSION OF PROPOSED DRAWING CORRECTIONS

RECEIVEL DOT 1007 C 1700 MAIL ROOM

Sir:

Submitted herewith are proposed drawing corrections, marked in red, to Figures 1A, 2A and 3A. If approved, such corrections will be incorporated into the formal drawings at the time of allowance.

Approval and acknowledgment of receipt are respectfully requested.

Respectfully submitted,

Sean M. McGinn

Registration No. 34,386

Date: 16/8/07
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